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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

AF  
#18/B  
7/22/03  
Naf

In re the Application of

Masashi UEDA et al.

Group Art Unit: 1763

Application No.: 09/830,879

Examiner: P. Hassanzadeh

Filed: May 2, 2001

Docket No.: 109426

For: INTERNAL ELECTRODE TYPE PLASMA PROCESSING APPARATUS AND  
PLASMA PROCESSING METHOD

**AMENDMENT AFTER FINAL REJECTION UNDER 37 CFR §1.116**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In further reply to the April 16, 2003 Final Office Action, and further to the July 10, 2003 Request for Reconsideration, and the July 11, 2003 personal interview between Applicants' representative and Examiner Hassanzadeh, please amend the above-identified application with sections as follows:

**Amendments to the Claims** are reflected in the listing of claims;

**Amendments to the Drawings** include an attachment sheet; and

**Remarks.**